Electronic Paten	t App	lication Fe	e Transm	ittal			
Application Number:	10	10549294					
Filing Date:	16	16-Sep-2005					
Title of Invention:	pu	Material for purification of semiconductor pollshing slurry, module for purification of semiconductor polishing slurry and process for producing semiconductor polishing slurry					
First Named Inventor/Applicant Name:	Mit	Mitsugu Abe					
Filer:	Ma	Marvin Jay Spivak/Genet Tsige					
Attorney Docket Number:	27	278426US0PCT					
Filed as Large Entity							
U.S. National Stage under 35 USC 371	Filing	Fees					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:					l		
Pages:				Δ			
Claims:			. 170				
Independent claims in excess of 3		1614	1	200	200		
Miscellaneous-Filing:							
Petition:	-						
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 2 months with \$0 paid	1252	1	450	450
Miscellaneous:				
	Tota	650		